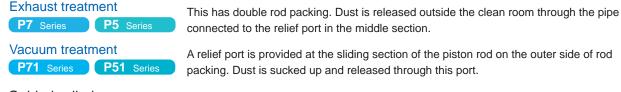
# Satisfies the various levels of clean room cleanliness in a wide range of industries.

### Air-operated actuator system selection guide

CKD offers various air-operated actuators as our major products for clean room specifications. The optimum model varies depending on the level of cleanliness and the location where the device is to be placed. Read the guideline carefully and choose the optimum model.

#### Standard cylinder



#### Guided cylinder

Low particle occurrence exhaust treatment

P72 Series

P52 Series

Double rod packing is incorporated as with the standard cylinder. Dust is released outside the clean room through the pipe connected to the relief port in the middle section.

Low dust grease is used in the sliding section (piston rod, quide rod, linear quide). Only greas.

Low dust grease is used in the sliding section (piston rod, guide rod, linear guide). Only grease is replaced as a countermeasure against dust generation from the guide area.

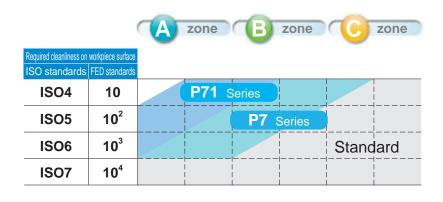
Low particle occurrence vacuum treatment
P73 Series
P53 Series

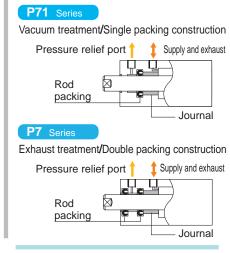
As with the standard cylinder, a relief port is provided at the sliding section of the piston rod on the outside of rod packing. Dust is sucked up and released through this port with vacuum. Low dust grease is used in the sliding section (piston rod, guide rod, linear guide). Only grease is replaced as a countermeasure against dust generation from the guide area.

Selection guide based on the relationship between the cleanliness of the clean room and the location where the device is to be placed Based on the required level of cleanliness on the surface of the workpiece, the air flow around the workpiece, and the cylinder location, select a model using the following table as a guide.

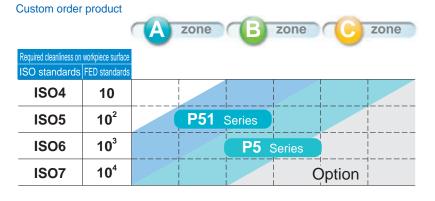
## Model for which its rod is the only sliding part/Standard cylinder (P\*/P\*1 Series)

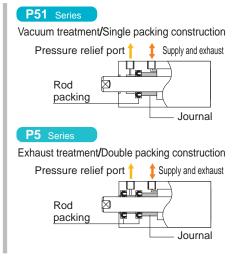
Pneumatic cylinder to control dust generation in a clean room (P7 Series)



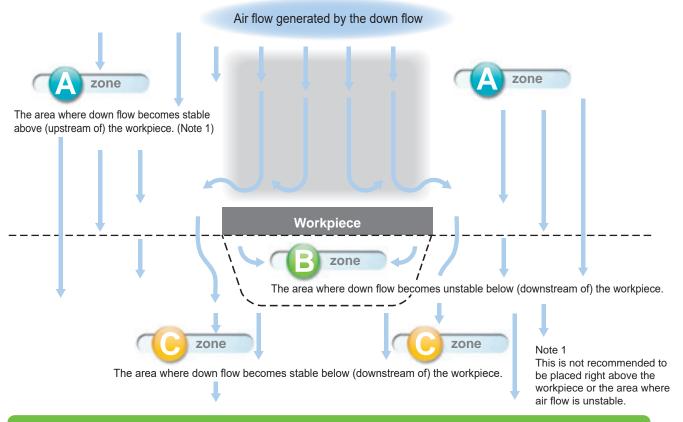


Pneumatic cylinder to control dust generation in a clean room and incompatible with copper-based, silicon-based and halogen-based materials (P5 Series)



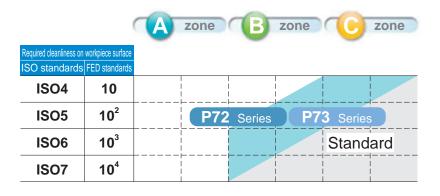


How dust generation affects cleanliness of the clean room depends on where the device is placed.



# Model which has external sliding parts/Guided cylinder (P\*2/P\*3 Series)

Pneumatic cylinder to control dust generation in a clean room (P7 Series)



Exhaust treatment/Double packing construction

Rod
packing

Pressure relief port

Supply and exhaust

P73 Series

Vacuum treatment/Single packing construction

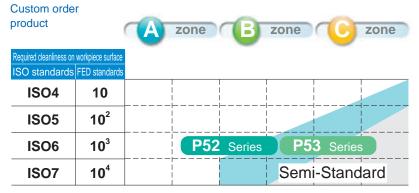
Rod
packing

Pressure relief port

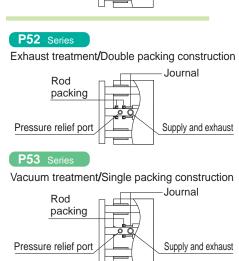
Supply and exhaust

Supply and exhaust

Pneumatic cylinder to control dust generation in a clean room and incompatible with copper-based, silicon-based and halogen-based materials (P5 Series)



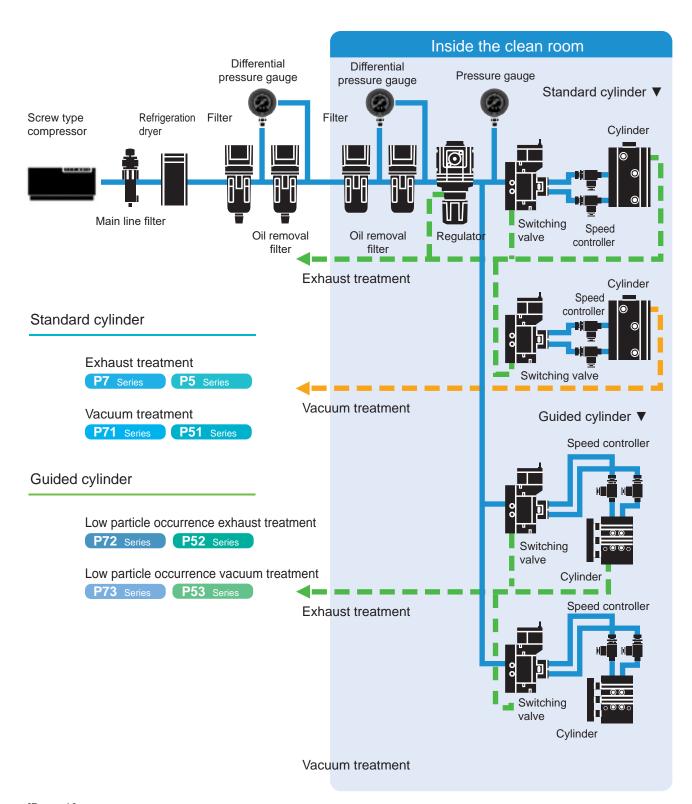
If the device has an external sliding part, A zone is not recommended as diameters of the particles are greater compared to the device for which its rod is the only sliding part.



# Targeting zero particle generation with vacuum and exhaust treatment.

## Air-operated actuator system circuit structure

This illustrates a typical circuit of an air-operated device system which consists of pneumatic cylinders, switchover valves, speed controllers, and F/R devices as a clean room device system. With this system, dust is sure to be released outside the clean room.



[Remark]

Note: Cylinders, switching valves, regulators, and filters should all have individual exhaust pipes. Do not share the exhaust piping.



# Two series of pneumatic cylinders for various applications.

(Exhaust treatment and vacuum treatment)



## Industry-specific clean room specifications for air-operated equipment systems

Construction of the pneumatic cylinder and materials vary depending on the industry for which the equipment is to be used. CKD offers two different groups of air-operated devices to satisfy different requirements for various industries. The clean room specifications shown here is for the pneumatic cylinders, which are the major components of the system.



Semiconductor



# Clean room specifications for LCD manufacturing

Standard

# **P7** Se

- Exhaust treatment port place in the piston rod sliding area
- Double packing construction



- Vacuum treatment port place in the piston rod sliding area
- Single packing construction

### Guided

Pneumatic cylinder series to control dust generation in a clean room.

#### P72 Series

- Exhaust treatment port place in the piston rod sliding area
- Double packing construction
- Low dust generation treatment of the guide area

#### P73 Series

- Vacuum treatment port place in the piston rod sliding area
- Single packing construction
- Low dust generation treatment of the guide area



Clean room specifications for manufacturing industries with material restrictions (custom order product)



Pneumatic cylinder to control dust generation in a clean room without using copper-based, silicon-based and halogen-based materials.



- Exhaust treatment port place in the piston rod sliding area
- Double packing construction
- Copper-based/silicon-based/ halogen-based materials (fluorine, chlorine, bromine) are prohibited

P51 Series Vacuum treatment port place in the

- piston rod sliding area Single packing construction
- Copper-based/silicon-based/ halogen-based materials (fluorine, chlorine, bromine) are prohibited

#### Guided

#### P52 Series

- Exhaust treatment port place in the piston rod sliding area
- Double packing construction
- Low dust generation treatment of the guide area
- Copper-based/silicon-based/halogen-based materials (fluorine, chlorine, bromine) are prohibited

#### P53 Series

- Vacuum treatment port place in the piston rod sliding area
- Single packing construction
- Low dust generation treatment of the guide area
- Copper-based/silicon-based/halogen-based materials (fluorine, chlorine, bromine) are prohibited



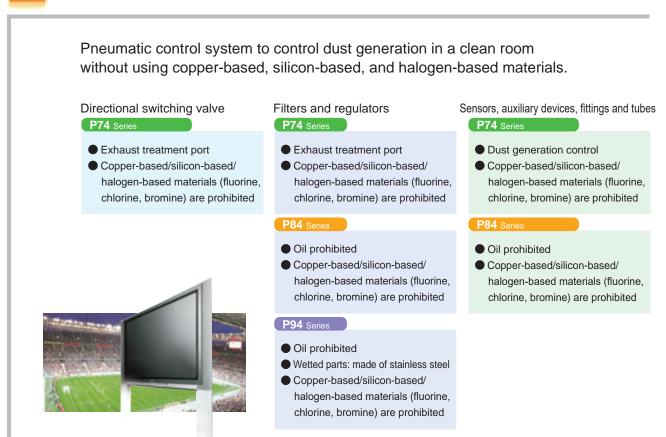
# Selecting the optimum pneumatic pressure control system for the application.

# Industry-specific clean room specifications for pneumatic control systems

Specifications for pneumatic valves, filters, and regulators vary from application to application. In this section, the clean room specifications of devices other than the pneumatic cylinder, such as directional switchover valves, filters, regulators, speed controllers, fittings and tubes are shown.



Clean room specifications for manufacturing industries with material restrictions



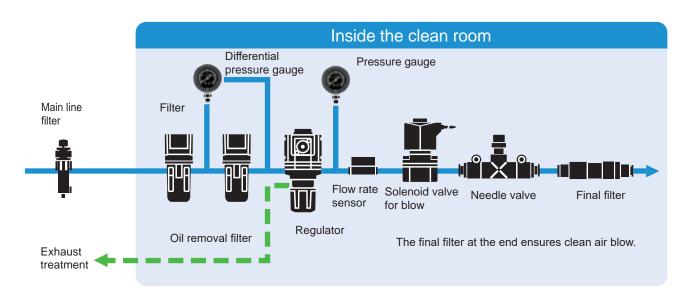
### CLEAN philosophy

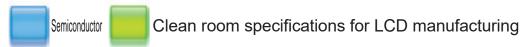
# Capable of steadily producing air of high cleanliness.



# Sample clean blow system circuit and industry-specific clean room specifications

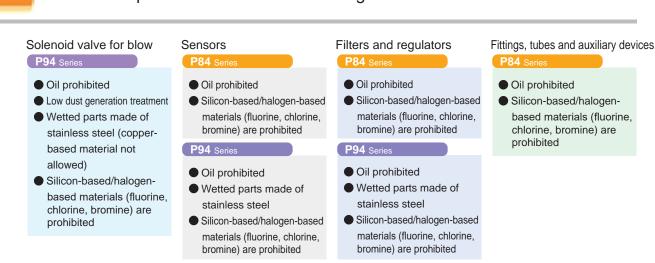
Recommended products and sample circuits for providing the air blow system with air of high cleanliness are shown. CKD offers two different groups of devices for the clean air blow system to satisfy different requirements for various industries. Clean room specifications for various industries are shown.







Clean room specifications for manufacturing industries with material restrictions



# ■ Clean room device system table

Major applications	Code	Basic spe	cifications	Models and remarks					
		Material restrictions		Cylinder	Pneumatic valves	Control valve	Electronic sensors	Filters and regulators	Tubes, fittings, and auxiliary devices
Semiconductor and LCD	<b>P7</b>	Fluorine-based grease is used	Exhaust treatment clean room package	0	_	_	_	—	—
	P70	(Dust generation control)		_	Exhaust treatment clean room package	_	Oil prohibited	Fluorine-based grease is used Exhaust treatment clean room package	Fluorine-based grease equivalent is used No sealing agent Clean room package
	P71	Fluorine-based grease is used	Vacuum treatment clean room package	0	_	_	_	_	_
	P72	Fluorine-based grease is used	Low dust generation treatment clean room package for the exhaust treatment guide area (Note 1)	0	_	_	_	_	_
	P73	Fluorine-based grease is used	Low dust generation treatment clean room package for the vacuum treatment guide area	0	_	_	_	_	_
	P80	Oil prohibited	Clean room package	_	_	_	0	Exhaust treatment	No sealing agent
	P90	Oil prohibited Stainless steel is used	Clean room package	_	_	Low dust generation treatment	_	Exhaust treatment	Copper-based materials prohibited (all parts) No sealing agent
Clean + Material restrictions	P5	Copper-based materials in (sliding and flow path parts) prohibited Silicon- and Halogen-based materials prohibited	Exhaust treatment clean room package	0	_	_	_	_	_
	P51	Copper-based materials in (sliding and flow path parts) prohibited Silicon- and Halogen-based materials prohibited	Vacuum treatment clean room package	0	_	_	_	_	_
	P52	Copper-based materials in (sliding and flow path parts) prohibited Silicon- and Halogen-based materials prohibited	Low dust generation treatment clean room package for the exhaust treatment guide area	0	_	_	_	_	_
	P53	Copper-based materials in (sliding and flow path parts) prohibited Silicon- and Halogen-based materials prohibited	Low dust generation treatment clean room package for the vacuum treatment guide area	0	_	_	_	_	_
	P74	Copper-, Silicon- and Halogen- based materials prohibited	Clean room package	-	Exhaust treatment	-	Copper-based materials prohibited (sliding and flow path parts) oil free	Fe materials prohibited PTFE (fluoroplastics) prohibited Fluorine-based grease is used for exhaust treatment	Fluorine-based grease prohibited No sealing agent
	P84	Copper-, Silicon- and Halogen- based materials prohibited, oil prohibited	Clean room package	_	_	_	Copper-based materials prohibited (sliding and flow path parts)	Fluorine-based grease is used for exhaust treatment	Fluorine-based grease prohibited No sealing agent
	P94	Copper-, Silicon- and Halogen- based materials prohibited, S.S. used, oil prohibited	Clean room package	_	_	_	0	Fluorine-based grease is used for exhaust treatment	_

Note 1: For MRL2 series, the sliding parts are processed to minimize dust.

# **Dust generation measuring method**

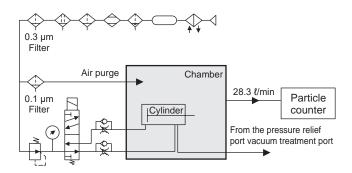
### Measuring instrument

Particle counter : Laser dust monitor

Minimum measurable

particle diameter : 0.1 µm Suction rate : 28.3 l/min

### Test circuit



### Measuring method

- 1. Place a cylinder in an antistatic chamber made of acrylic or stainless steel.
- 2. Send clean air passed through a 0.1 µm filter at the same flow rate as the particle counter suction rate (28.3 l/min).
- 3. Confirm that the particle counter value is zero before you start operating the cylinder.
- 4. Operate the cylinder, and measure particles generated during the operation.

Note: A sealed chamber is used so that particles other than those generated from the test cylinder do not enter the chamber.

## Measuring conditions

· Quality of air

For driving the cylinder: "Grade 2.2.1" (JIS B8392-1)

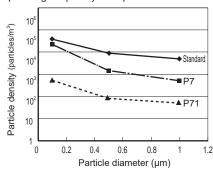
For purging: "Grade 2.2.1" +0.1 µm gas filter

- Cylinder supply pressure: 0.5 MPa
- Cylinder operating speed: general speed (200 mm/s)
- Operating condition: no load; horizontally mounted (parallel to the purge flow)
- Relief port for exhaust treatment is connected and released outside the chamber.
- Vacuum port for vacuum treatment is connected and vacuum treated at -26 KPa.

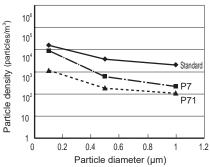
# **Dust generation measuring**

- MRL2 (port size 16, stroke length 200)

Number of endurance cycles: initial state Operating frequency: 40 cpm



Number of endurance cycles: initial state Operating frequency: 30 cpm



Number of endurance cycles: initial state Operating frequency: 30 cpm

